

**High-pressure Gas Equipment****Liquefied Gas Automatic Supply System****Optimal for stable supply of liquefied gas!**

This system is widely used in various fields such as semiconductor manufacturing equipment, cooling test equipment, and food processing equipment.

**Specifications**

|                                               |                                                                                        |
|-----------------------------------------------|----------------------------------------------------------------------------------------|
| <b>Primary pressure</b>                       | 1.11 MPa (max.)                                                                        |
| <b>Secondary pressure</b>                     | 0.05 to 0.2 MPa (Controlled by the control valve)                                      |
| <b>LN2 volume inside gas-liquid separator</b> | 20 to 100L (To be designed for applications.)                                          |
| <b>LN2 supply system</b>                      | Differential pressure liquid level control, or load cell type load control             |
| <b>Flow rate per hour</b>                     | 500 L/H (max.)                                                                         |
| <b>Others</b>                                 | Conforming to the Specific Equipment Inspection under the High Pressure Gas Safety Law |